

# **A facile hydrothermal approach for the density tunable growth of ZnO nanowires and their electrical characterizations**

Sarah Boubenia, Abhishek Singh Dahiya, G. Poulin-Vittrant, François Morini, Kevin Nadaud, D. Alquier

### **To cite this version:**

Sarah Boubenia, Abhishek Singh Dahiya, G. Poulin-Vittrant, François Morini, Kevin Nadaud, et al.. A facile hydrothermal approach for the density tunable growth of ZnO nanowires and their electrical characterizations. Scientific Reports, 2017, 7 (1),  $10.1038/s41598-017-15447-w$ . hal-01867142

## **HAL Id: hal-01867142 <https://hal.science/hal-01867142v1>**

Submitted on 5 Jan 2024

**HAL** is a multi-disciplinary open access archive for the deposit and dissemination of scientific research documents, whether they are published or not. The documents may come from teaching and research institutions in France or abroad, or from public or private research centers.

L'archive ouverte pluridisciplinaire **HAL**, est destinée au dépôt et à la diffusion de documents scientifiques de niveau recherche, publiés ou non, émanant des établissements d'enseignement et de recherche français ou étrangers, des laboratoires publics ou privés.

# SCIENTIFIC REPERTS

Received: 29 August 2017 Accepted: 27 October 2017 Published online: 09 November 2017

# **A facile hydrothermal approach OPENfor the density tunable growth of ZnO nanowires and their electrical characterizations**

**S. Boubenia<sup>1</sup>, A. S. Dahiya<sup>1</sup>, G. Poulin-Vittrant<sup>2</sup>, F. Morin[i](http://orcid.org/0000-0003-3068-4776) <sup>1</sup>, K. Nadaud <sup>1</sup> & D. Alquier<sup>1</sup>**

**Controlling properties of one-dimensional (1D) semiconducting nanostructures is essential for the advancement of electronic devices. In this work, we present a low-temperature hydrothermal growth process enabling density control of aligned high aspect ratio ZnO nanowires (NWs) on seedless Au surface. A two order of magnitude change in ZnO NW density is demonstrated** *via* **careful control of the ammonium hydroxide concentration (NH4OH) in the solution. Based on the experimental observations, we further, hypothesized the growth mechanism leading to the density controlled growth of ZnO**  NWs. Moreover, the effect of NH<sub>4</sub>OH on the electrical properties of ZnO NWs, such as doping and field**efect mobility, is thoroughly investigated by fabricating single nanowire feld-efect transistors. The electrical study shows the increase of free charge density while decrease of mobility in ZnO NWs with the increase of NH4OH concentration in the growth solution. These fndings show that NH4OH can be used for simultaneous tuning of the NW density and electrical properties of the ZnO NWs grown by hydrothermal approach. The present work will guide the engineers and researchers to produce lowtemperature density controlled aligned 1D ZnO NWs over wide range of substrates, including plastics, with tunable electrical properties.**

ZnO nanostructures such as nanowires (NWs), nanorods, and nanosheets have received considerable attention of the research community for the fabrication of electromechanical, electronic and optoelectronic devices, such as  $s$ ensors<sup>1</sup>, energy harvesters<sup>2,3</sup>, field-effect transistors (FETs)<sup>4-7</sup>, and light emitting diodes<sup>8,9</sup>. The increased interest in ZnO nanomaterial has been largely driven by its excellent electrical and optoelectronic properties, including direct wide band-gap  $(3.37 \text{ eV})^{10,\tilde{\text{11}}}$ , high exciton binding energy  $(60 \text{ meV})^{\tilde{\text{11}}}$ , and high electron mobility (1 to 200 cm<sup>2</sup>/Vs) as well as high piezoelectric coefficient<sup>1</sup>( $d_{33}$  ~12 pm/V). In the continual research effort for miniaturization of electronic devices, quasi one-dimensional (1D) ZnO nanowires (NWs), proved to be a potential candidate due to their unique properties, such as high electromechanical coupling factor and improved charge injection/extraction at metal-semiconductor junction<sup>12</sup>. Varieties of bottom-up approaches, including pulse laser ablation<sup>13</sup>, flamme transport approach<sup>14–17</sup>, vapor-liquid-solid<sup>18</sup>, electrochemical deposition<sup>19</sup>, hydrothermal and/ or chemical bath deposition<sup>2,6,11,20,21</sup> have been exploited for the synthesis of 1D ZnO NWs. However, most of the techniques are limited by their high temperature process that cannot be scaled up over large device area at very low cost. The need of an industrially scalable low-temperature ZnO NWs synthesis method has seen significant advancements towards the hydrothermal growth process. Hydrothermal growth (HTG) is a low temperature process where single-crystalline 1D material can be produced on various substrates, including plastics and textile fibers<sup>22</sup>. High-density ZnO NWs, perpendicular to the growth substrate, has often been reported employing HTG process<sup>6</sup>. However, perfect control of the ZnO NW's density, aspect ratio and alignment with controlled electrical properties has rarely been reported. Moreover, it has been shown, both by simulations and experimental results, that the performances of electronic devices, such as piezoelectric nanogenerators, rely strongly on density and electrical properties of grown ZnO NWs<sup>21,23</sup>.

1 Université François Rabelais de Tours, CNRS, GREMAN UMR 7347, 16 rue Pierre et Marie Curie, 37071, Tours Cedex2, France. <sup>2</sup> Université François Rabelais de Tours, INSA-CVL, CNRS, GREMAN UMR 7347, 3 rue de la Chocolaterie, CS 23410, 41034, Blois Cedex, France. Correspondence and requests for materials should be addressed to S.B. (email: [sarah.boubenia@univ-tours.fr](mailto:sarah.boubenia@univ-tours.fr))

To control the density, uniformity and alignment of NWs, selective area HTG process has been used in the past. It has been demonstrated using different lithography technologies, including nanosphere lithography<sup>24</sup>, electron-beam (e-beam) lithography<sup>25</sup>, and laser interference lithography<sup>26</sup>. For instance, employing high resolution e-beam lithography, Consonni *et al*. 25 reported position, vertical alignment, dimensions, and polarity controlled growth of ZnO NWs over large surface areas. However, adoption of these approaches are restricted due to many limitations such as: (i) use of expensive and complicated equipment added to cost and complexity of the fnal device, (ii) incompatibility with fexible substrates, and (iii) unscalability at industrial level. To mitigate these limitations, seedless density controlled growth of ZnO NWs, on Au surface, has been proposed eliminating the use of any lithography technique<sup>27</sup>. Such a growth approach has shown distinctive advantages, including: (i) low growth temperature enabling direct integration of NWs for the fabrication of functional devices onto organic substrates, (ii) tight control over size, orientation, and density of produced NW, and (iii) cost-efective. In most of the existing literature on seedless growth of ZnO NWs, the density is limited to one order variation. For instance, Xu *et al.* demonstrated one order change of NW density, by varying growth precursor concentration<sup>27</sup>. However, the exact growth mechanism leading to the variation of NW density is still unclear. Moreover, the consequence on the electrical properties, such as mobility and free charge density, related to the variation of growth nutrients and/or parameters to control the NW density, has not been performed.

A facile low temperature growth approach for 1D ZnO NWs with controlled morphology and density is a potential solution to master nanodevice fabrication cost. Furthermore, the direct integration of such quasi 1D nanostructures over metal electrodes not only reduces the fabrication cost but also the complexity of the fabrication process. A thin ZnO seed layer and/or ZnO nanoparticles is required for the growth of ZnO  $NWs^{11}$ . Consequently, the presence of such ZnO layer between the metal electrode and NWs may increase the contact resistance, which has detrimental efect over the device performances due to poor charge injection / extraction across metal-semiconductor (MS) contact interface. The poor charge transport across MS contact can be improved by direct integration of ZnO NWs onto a metallic substrate such as Au metal electrode, like in the present study. Furthermore, we show a facile and efective HTG process to achieve high degree control over the ZnO NWs density on Au surface. More than two orders of NW density variation will be demonstrated by careful addition of NH4OH, as an additive, in the growth solution. Based on the experimental observations, we will hypothesize the mechanism leading to the density controlled growth of ZnO NWs. To follow the efect of NH4OH on the electrical properties of ZnO NWs, we will fabricate single ZnO nanowire feld-efect transistors (NW-FETs) on Si/SiO<sub>2</sub> substrates. The detailed statistical data of mobility and free charge density for ZnO NWs, grown with diferent NH4OH concentrations, will be presented.

#### **Experimental part**

The ZnO NWs are grown by (HTG) process on (100) oriented Si wafers. A sample of  $4 \text{ cm}^2$  rigid silicon is first cleaned in piranha solution (1:1 H<sub>2</sub>SO<sub>4</sub> and H<sub>2</sub>O<sub>2</sub>) for 10 min followed by 2 min dip in hydrofluoric acid (50%) to remove the thin oxide formed during piranha cleaning and fnally, rinsing in DI water. Tis clean step is followed by drying with nitrogen gas and a fnal baking step is performed at 200 °C to remove any adsorbed moisture before the metal deposition. A gold layer (~200 nm thick) is then deposited by direct current sputtering technique at room temperature. To improve the adhesion between gold and silicon, we deposit a layer of titanium  $(-100 \text{ nm})$  using the same technique. The reactant precursor consists of 1:1 ratio of zinc nitrate hexahydrate  $(Zn (NO<sub>3</sub>), 6H<sub>2</sub>O, 98%)$  and hexamethylenetetramine (HMTA). During the growth, the substrates are immersed facing down in a Tefon fask, sealed inside stainless steel autoclave reactor and placed in a preheated convection oven for 15 hours. The autoclave is taken out from oven and cools down naturally. The substrates are then thoroughly rinsed with flowing DI water and dried in  $N_2$  gas flow. In the experiments, the concentration of NH<sub>4</sub>OH is varied from 0 to 40 mM. The obtained ZnO NWs are examined under 10 kV of energy using Hitachi scanning electron microscope (SEM). The surface morphology of the as-deposited Au films is accessed using an atomic force microscopy (AFM). The AFM images are performed using a Nanoscope V (Bruker<sup>®</sup>) in tapping mode. The tip used is a non-conductive RTESP (MPP11100-10) probe with a resonance frequency of about 300 kHz and a spring constant of around 40N/m.

ZnO NWs crystallinity is studied using x-ray diffraction (XRD) with CuK $\alpha_1$  radiation on the high resolution parallel beam diffractometer Bruker D8 discover. The scans are performed in the 2 $\theta$  range from 25 $\degree$  to 50 $\degree$ at a scanning rate of 0.01° s<sup>−1</sup>. Room temperature Raman spectra of as grown ZnO NWs are obtained using a Renishaw Invia Refex instrument. An excitation wavelength of 514.5nm and a power of 1mW is used. A lens of 100x magnifcation is used to focus the laser beam and, to collect the scattered light dispersed by a holographic grating with 2400 lines/mm. The diameter of the resulting laser spot is around  $1 \mu m$ .

For the extraction of electrical properties of NWs, we have fabricated bottom-gate single ZnO NW-FET on highly doped Si substrates with 170 nm thick thermally grown  $SiO<sub>2</sub>$ . Fabrication of ZnO NW-FET devices is done using standard electron-beam lithography (EBL) process as follows: Following the growth of ZnO NWs by the HTG process, substrates are annealed in air ambient at 450 °C for 30 min. The annealed substrates are inserted into a vial flled with the desired solvent (isopropanol (IPA) in the present case). A brief agitation, on a sonic bath (5–10 sec), yields sufficient release and subsequent suspension of NWs in IPA solvent. The NWs solvent formulation is transferred directly (by drop-casting) onto the various device substrates using pipette. To defne the source/drain (s/d) contacts on the single ZnO NW, EBL is performed. The s/d contact metallization is performed by electron beam evaporation at vacuum ≤10<sup>-6</sup> mbar. The formation of ohmic s/d contacts for the devices is achieved using low work-function metals Ti/Al (100/400nm). Afer metallization, the e-beam resist mask and unwanted metal layers are stripped from the surface of the substrates using acetone. This is followed by annealing the devices at 150 °C for 30 min on a hot plate in order to evaporate any residual solvent and/or water vapours from the NW surface and contact interface. This step improves the ohmicity of the metal-semiconductor (MS) contact interface, needed for the better extraction of semiconducting material properties. A Cascade Microtech



**Figure 1.** SEM images of NWs grown for diferent concentrations of ammonia: (**a**) 0mM, (**b**) 10mM, (**c**) 20mM, (**d**) 30mM, (**e**) 40mM. Te inset in each panel a-e shows the top view SEM image acquired from the same sample. The scale bar in the inset is 500 nm. (**f**) Panel shows the variation of density of NWs with the change in NH4OH concentration.



Table 1. The aspect ratio of ZnO NWs with the variation of ammonium hydroxide.

Summit 11k probe stage equipped with a source measure unit (2636A, a double channel source measuring unit by Keithley instrument) is used to perform current voltage measurements under dark ambient conditions. Tungsten metallic probes are used to contact NW-FET device electrodes for the electrical measurements.

#### **Results and Discussion**

To control the density of ZnO NWs, ammonium hydroxide (NH4OH) has been used as an additive into the growth solution. The obtained growth results while varying NH<sub>4</sub>OH concentrations (from 0 to 40 mM by step of 10mM) in the growth solution are presented in Fig. 1 (panel a-e); showing typical cross-sectional and top-view SEM images acquired from the ZnO NW samples. It can be seen from SEM images that the obtained NWs are almost perfectly aligned perpendicularly to the growth surface for all NH4OH concentrations. Using the SEM images, NW densities are extracted for all cases and the results are shown in Fig. 1 (panel f). From this graph, an increase in the NW density, defned as the number of NWs per square centimetre, can be detected when NH4OH concentration increases from 10mM to 40mM. As can be seen from Fig. 1f, an approximately two orders change in NW density can be obtained by careful control of NH4OH concentration in the growth solution. Going along with density, aspect ratio (AR) of the nanomaterial greatly determines / conditions their application in fexible electronics where high surface to volume ratio are needed for increased strain absorption. Hence, variation in NW's AR, with the increase of NH4OH concentration, is also calculated using another set of SEM images. In order to have almost correct quantitative data for aspect ratio (due to their conical shape), we dispersed NW on another substrate and acquired SEM images for various NWs and the mean values are shown in Table 1. The diameter of ZnO NWs is determined from both tip (for  $AR_{tip}$ ) and base (for  $AR_{base}$ ) to take into account the possible change of their shape. It can be seen from Table 1, that there are very little variations of  $AR_{base}$ , even though there is large variation in the length of NWs. On the other hand, a large variation of  $AR_{tip}$  is found with the change in NH<sub>4</sub>OH concentration, reaching a maximum value of 30 for 20 mM NH<sub>4</sub>OH. The obtained AR<sub>tip</sub> values for all growth conditions are comparable to the other reported values for ZnO NWs grown on Au surface<sup>28</sup>. The growth mechanism leading to the large NW density variations with varying NH4OH concentrations is discussed in the following section.

**Growth mechanism.** Although the exact chemical reactions during the HTG of ZnO NWs is still unclear, we have hypothesized, based on the experimental observations, the growth mechanism for the density controlled



**Figure 2.** Growth mechanism for the density controlled growth of ZnO NWs: (**a**) low density, and (**b**) high density case.

growth of ZnO NWs on seedless growth substrates. The growth mechanism is schematically illustrated in Fig. 2, based on the analysis and growth models reported in the literature<sup>20,29</sup>. The following equations describe the dominant chemical reactions leading to the growth of ZnO NWs. First, HMTA and zinc nitrate salts can hydrolyze to produce ammonia and formaldehyde as well as zinc ions, respectively, as per the following equations:

$$
(\text{CH}_2)_6\text{N}_4 + 6\text{H}_2\text{O} \leftrightarrow 4\text{NH}_3 + 6\text{CH}_2\text{O} \tag{1}
$$

$$
Zn(NO_3)_2 \to Zn^{2+} + 2NO_3^- \tag{2}
$$

Further, zinc nitrate ions can react directly with HMTA (Equation 3) and/or  $NH<sub>3</sub>$  ions (Equation 4), produced in Equation 1, to provide positively charged Zn (II) complex:

$$
(\text{CH}_2)_6\text{N}_4 + \text{Zn}^{2+} \leftrightarrow [\text{Zn}(\text{C}_6\text{H}_{12}\text{N}_4)]^{2+} \tag{3}
$$

$$
\text{Zn}^{2+} + 4\text{NH}_3 \leftrightarrow \text{Zn}(\text{NH}_3)_4^{2+} \tag{4}
$$

On the other hand, negatively charged Zn (II) complexes can also be formed according to Equation 5:

$$
\text{Zn}^{2+} + 4\text{OH}^- \leftrightarrow \text{Zn}(\text{OH})_4^{2-} \tag{5}
$$

Under given pH and temperature conditions, Zn (II) may exist primarily as  $Zn(OH)_4^{2-}$  or  $Zn(NH_3)_4^{2+}$ . ZnO NWs are formed on substrates, by the condensation (dehydratation) of these Zn (II) complexes (Equations 6–8):

$$
Zn(NH_3)_4^{2+} + H_2O \leftrightarrow ZnO + 4NH_3 + 2H^+ \tag{6}
$$

$$
Zn(OH)42- \leftrightarrow ZnO + H2O + 2OH-
$$
 (7)

$$
[Zn(C_6H_{12}N_4)]^2 + 2OH^- \leftrightarrow ZnO + H_2O + C_6H_{12}N_4
$$
\n(8)

All these reactions occur in equilibrium and, hence, can be controlled by tuning the reaction parameters, such as precursor concentration, pH, and temperature.

The formation of ZnO nucleation growth sites, on Au surface, is a complicated task to accomplish. To initiate the nucleation process on Au surface, diferent techniques have been reported in the literature to introduce the negative charges over the Au surface to attract the positively charged zinc (II) complexes, formed during Equations 2 and 4. Some of these propose applying negative potential of 500 mV to the Au surface<sup>29</sup> or activating Au surface using chemical treatments<sup>30</sup>. However, it is to note that, in the present case, we have employed no such extra step to initiate the nucleation process which eases the present growth approach.

In general, the surface roughness of the growth substrate have shown major efect on the orientation and quality of the NW produced<sup>27</sup>. In this work, the gold layer is (111) oriented as shown in Fig. 3a. The surface



**Figure 3.** (**a**) XRD and (**b**) Raman spectroscopy acquired from ZnO NWs grown with diferent ammonium hydroxide concentrations.

topography of the Au (111) sputtered flm is characterized using atomic force microscopy (AFM) before starting the growth process. From the AFM characterization results (not shown here), a low RMS roughness value  $(\sim 2$ nm) is revealed, confirming the presence of a smooth Au (111) surface ideal for the growth of highly aligned ZnO NWs<sup>27</sup>. It is to note that no extra annealing step is carried to improve the crystalline quality of Au film. Most of the existing literature shows that the zinc oxide nanostructures are formed by the hydrolysis of zinc nitrate and HMTA29. Although the precise role of HMTA is still unclear, it is believed that it can act as a Lewis base with metal ions and a bidentate ligand capable of bridging two zinc(II) ions in solution<sup>29</sup>.

Moreover, according to the crystal growth theory, a requisite for the nucleation of a seed is the development and continuous presence of the supersaturation in the growth solution to provide a thermodynamic force to permit a spontaneous growth of the nuclei<sup>20</sup>. It has been reported that heating ammoniac solution containing dissolved zinc complexes provides this thermodynamic driving force for the ZnO synthesis<sup>20</sup>. In the present case, with very less  $NH<sub>4</sub>OH$  (10 mM), the pH of the growth solution is around 6.8. At this pH and temperature range (358 K), there are very few positively charges Zn (II) complex species present in the growth solution<sup>20</sup>. Such a low concentration of the ZnO precursors results into the low density of nucleation sites for the growth of ZnO NWs (Fig. 2a). When increasing the NH4OH concentration from 10 to 40 mM, the pH of the system increases from 6.8 to around 7. Although the change in pH is very low (between 6.8 and 7), there is an exponential change of the Zn (II) species in this pH regime<sup>20</sup>. In fact, this increase of pH leads to the increase of Zn (II) in the solution, which will largely decrease the Zn solubility and lead to a supersaturation large enough to initiate large number of nuclei both in the solution and onto the substrate. This causes a high concentration of the ZnO precursors to become localized at Au surface. Thus, enhanced nucleation sites could be achieved for the 40 mM NH<sub>4</sub>OH concentration (Fig. 2b).

The formation of the perfect hexagonal prism shaped NWs can be explained in accordance with the surface energies of the three lower index planes of ZnO, namely (0001),(000I), and (1I00). The Wurtzite ZnO has polar surfaces, i.e. (0001), (0001) and non-polar surfaces (1120) and (1010). In general, under thermodynamic equilibrium conditions, the facet with higher surface energy is usually small in area, while the lower energy facets are larger<sup>10</sup>. The surface energy for the ZnO's lower index planes are in the following order: (0001) > (1120) > (1010). Consequently, in the ZnO growth, the highest growth rate is along the c-axis and the large facets are usually  $(11\overline{2})$ 0) and (1010). It has been proposed that the preferential adsorption of the negatively charged species onto the positively charged (0001) surface of ZnO leads to the anisotropic growth of rod like structures<sup>20</sup>.

A two orders of NW density control using NH4OH is impressive. However, addition of ammonia in the solution may have an adverse effect on the crystalline quality of ZnO NWs<sup>31</sup>. To follow the crystallinity of the obtained NWs, we have carried out XRD and Raman spectroscopy measurements, as shown in Fig. 3. The XRD spectra recorded from the various NW samples grown with diferent NH4OH concentrations are shown in Fig. 3a. As we can see, ZnO NWs show dominant peak at  $2\theta = 34.4^{\circ}$ corresponding to (0002) plane reflections. This observation shows that ZnO NWs arrays exhibit strong preferential c-axis orientation vertically to the growth substrates. In addition, no signifcant shif is observed in the dominant ZnO related peak (0002) with increasing the ammonia concentration, indicating the absence of any additional induced stress in the NWs. Tese observations lead us to conclude that there is no distortion of the ZnO lattice parameter with the NW density change. Moreover, there is no other extra peak related to any impurities which indicates that the NWs, for different NH<sub>4</sub>OH concentrations, have pure wurtzite crystal structure. The additional dominant peak appearing at  $2\theta = 38.3^\circ$  is assigned to Au (111). The crystalline quality of as-grown ZnO NWs is further confirmed by micro-Raman measurements, as shown in Fig. 3b. The Micro-Raman spectroscopy is a powerful characterization tool to detect level of point defects, doping and change of crystalline structure of the obtained material. As observed in the Fig. 3b, all the spectra recorded for various NH4OH concentrations at room temperature, exhibit the Raman modes typical of the wurtzite crystal structure, as indicated by the XRD measurements. The two dominant peaks centred at 98.3 and 437.5 cm<sup>−1</sup> are successfully assigned to the two non-polar first-order Raman active E2 (low) and E2 (high)



**Figure 4.** (**a**) Schematic and (**b**) atomic force microscopy image of a typical NW-FET fabricated on 170nm thick  $SiO<sub>2</sub>$ .

modes, described by the Raman selection rules for wurtzite ZnO (with C6v point group symmetry). Similarly to XRD measurements, the ZnO frequency Raman modes remain unchanged whatever the NH4OH concentration of this study and no additional mode is detected. Tis confrms the formation of the wurtzite structure. Moreover, both the peaks are found to show very low full width half maximum (FWHM) values of 3 and 7, respectively. Such low FWHM values for NWs grown with all NH<sub>4</sub>OH cases, suggest the production of high ZnO crystal quality<sup>32</sup>. The peak appearing at 332 cm<sup>-1</sup> is the second order scattering from phase boundaries of ZnO.

It is indeed important to control the electrical properties of the 1D nanomaterial for the advancement of electronic, optoelectronic and electromechanical devices, such as piezoelectric nanogenerators<sup>2</sup>. It is well known that ZnO material, irrespective bulk or nanostructures, are always unintentionally n-type doped. The cause of this unintentional n-type conductivity has been widely discussed in the literature, and has ofen been attributed to the presence of native point defects, such as oxygen vacancies and zinc interstitials<sup>33,34</sup>. The addition of ammonia during the hydrothermal growth process has shown to introduce additional point defects observed using optical characterization techniques, such as photoluminescence which will afect the electrical properties of the material<sup>31</sup>. Nevertheless, no such statistical study has been performed to evaluate the effect of NH<sub>4</sub>OH on the electrical properties of the nanomaterial. Hall-efect measurements is the commonly used technique to study the charge transport in thin-flms or bulk, however in case of 1D NWs, it is very complicated to implement Hall measurements due to the limitation of the size of the material. In general, for 1D nanostructures, electrical characterization of the material is performed through the fabrication of single NW field-effect transistors (NW-FETs)<sup>6</sup>. In the present work, to evaluate the efect of NH4OH on the electrical parameters of the NWs, bottom-gate single NW-FETs are fabricated on  $Si/SiO<sub>2</sub>$  substrates. Figure 4 shows the schematic and typical atomic force microscopy (AFM) image of the fabricated NW-FET device. It can be seen, using the AFM image, that the NW is perfectly covered by source/drain (s/d) electrodes, a feature needed for the efficient charge transport across metal-semiconductor interface.

To evaluate the efect of NH4OH on the electrical properties, we fabricate single NW-FETs using NWs grown with 0, 20 and 40 mM of ammonium hydroxide. It is to note that all the NWs are thermally annealed under same conditions (450 °C in air for 30 min) in order to have feld-efect modulation of current, that will enable the extraction of electrical parameters<sup>6</sup>. The resulting electrical characterization results, output and transfer curves, for diferent NH4OH concentrations (0, 20, and 40mM), are shown in Fig. 5 along with their respective device SEM images. The output characteristics are shown in Fig. 5a,c and e for 0, 20 and 40 mM concentration of NH<sub>4</sub>OH, respectively. The observed increase in drain-source current ( $I_{DS}$ ) with the incremental increase of gate-source voltage (*V<sub>GS</sub>*) towards the positive values, in the output scans, shows the n-channel behaviour of the NW-FET devices for all cases. Note that the output scans also demonstrate a linear dependence of  $I_{DS}$  with increasing drain-source voltage ( $V_{DS}$ ) (at  $V_{DS} \leq 0.1$  V), and nicely saturating at higher  $V_{DS}$  values confirming a tight gate control over the NW channel, a feature needed for the extraction of the near real electrical parameter values of the semiconductor material. To obtain the transfer scans, the  $V_{GS}$  is swept from negative towards positive *V*<sub>GS</sub> at a fixed *V*<sub>DS</sub> of 1 V. The resulting curves are shown in Fig. 5 panel's b (0 mM), d (20 mM) and f (40 mM). From these transfer scans, it can be seen that increasing  $V_{GS}$  towards positive values resulted to an increase in  $I_{DS}$ . This device behaviour suggests an n-channel accumulation-type FET. A linear extrapolation of  $I_{DS}$  to  $V_{GS}$ interception reveal the threshold voltage  $(V_{TH})$  of the device. Using the transfer characteristics, important electrical data of the semiconductor NWs, such as mobility and charge density can be extracted using the following equations:<sup>6</sup>

$$
\text{Field–effect mobility, } \mu_{FE} = \frac{g_m \times L^2}{V_{DS} \times C_{NW}} \tag{9}
$$



**Figure 5.** Electrical characterization results for ZnO NW-FETs fabricated using NWs grown using diferent NH4OH concentrations: (**a**,**b**) 0 mM, (**c**,**d**) 20 mM and (**e**,**f**) 40 mM. Te inset shows the SEM image of the NW-FET.



**Table 2.** Key parameters extracted from NW-FET fabricated with NWs grown with varying ammonium hydroxide concentration.

$$
\\
$$

Free charge density, 
$$
n_e = \frac{C_{NW}V_{TH}}{2\pi r^2 qL}
$$
 (10)

Where  $g_m$  is the transconductance (d $I_{DS}/ dV_{GS}$ ), *L* is the channel length, *r* is the radius of NW, q is the elementary charge and  $C_{NW}$  is the gate capacitance given by:

$$
C_{NW} = \frac{2\pi\varepsilon_0\varepsilon_{ox}L}{\cosh^{-1}\left(\frac{r_{NW} + t_{ox}}{r_{NW}}\right)}
$$
(11)

where  $\varepsilon_0$  is the absolute permittivity,  $\varepsilon_{ox}$  is the silicon oxide permittivity (3.9) and  $t_{ox}$  is SiO<sub>2</sub> thickness (170 nm).

To have the statistical data distributions for charge density and mobility values, we have fabricated 5 NW-FET devices for each NH<sub>4</sub>OH concentration. The data distribution is shown in Table 2. It can be seen from Table 2, that all the NW-FET devices showed impressive on/off current ratio which may find them applications in digital electronics as switches. The precise values of mobility and charge density are difficult to extract using FET device configuration which generally shows large data variations from device to device<sup>4</sup>. The large variations of electrical



Figure 6. Graph depicting the variation of mobility and free chare density with the addition of NH<sub>4</sub>OH in the growth solution.

parameters, such as mobility, may be due to the quality of the s/d contact interfaces, which can contain some insulating surface layers. Such layers can arise from: (1) the presence of residual resists from the assembly stage and/ or (2) unfavorable chemical reactions between metal s/d contacts and ZnO surface<sup>35</sup>. As can be seen from Table 2, there is large  $V<sub>TH</sub>$  variation from device to device in the present case also which affects the extraction of precise value for free charge density (Equation 10). We acknowledge that, in the present work, we have not mastered the threshold voltage of ZnO NW-FETs, where the value varies largely. In thin flm transistors and/or nanomaterial based FETs, which work in depletion/accumulation mode,  $V<sub>TH</sub>$  is influenced by many factors, such as charge density in the nanomaterial, energy bands at both s/d metal-semiconductor contact interface, dielectric/semiconductor interface quality and adsorbed species on semiconductor channel<sup>32</sup>. From Table 2, the average  $V_{TH}$ values of NW-FET devices fabricated for each NH4OH concentration become more negative when we introduce NH<sub>4</sub>OH in the growth solution. The additions of NH<sub>4</sub>OH is supposed to introduce extra point defects in the NWs which degrade the high quality of the nanomaterial produced and hence increase the charge density in the NWs. It is also to note from Table 2 that FET devices fabricated with NWs obtained by addition of NH4OH showed large V<sub>TH</sub> variation ( $\pm$ 18V) compared to the one without ammonium hydroxide ( $\pm$ 4.7). Such a large variation in  $V<sub>TH</sub>$  can arise from the creation of extra defect carrier trap centres at the metal-semiconductor (MS) contact, which will degrade the quality of the charge transport in the material. Investigating the exact cause of such device to device  $V_{TH}$  variation is beyond the scope of the present manuscript, therefore this  $V_{TH}$  variation will be more deeply investigated in a future work by post-treatments on the FET devices such as annealing in oxygen ambient and/or ozone treatment<sup>32,36</sup>. However as all the fabrication steps for different devices are performed under identical conditions, therefore it is fair to compare the NW electrical parameters values such as mobility and free charge density, obtained from diferent devices.

The extracted average mobility and charge density values with possible errors are shown in Fig. 6. As it can be seen from this set of data, with increasing NH4OH concentration, the free charge carrier density increases from  $4.3\times10^{16}$  to  $2\times10^{17}$  cm<sup>-3</sup> while field-effect mobility decreases from 3.8 to 0.35 cm<sup>2</sup>/Vs as the NH<sub>4</sub>OH concentration increases from 0 to 40 mM. These observations suggest that with increasing amount of NH<sub>4</sub>OH concentration in the growth solution, the amount of free charge density increases inside ZnO NWs. The increase of free charge density can be correlated with the increase of point defects, such as oxygen vacancies or Zn interstitials. These defects, commonly observed on ZnO nanowires grown by hydrothermal method, are enhanced with the addition of NH<sub>4</sub>OH, as it is reported in literature<sup>31</sup>. Free charge density values, deduced from the electrical characterization performed on the ZnO nanowires, confrm this trend with increasing NH4OH concentration, as shown in Fig. 6.

#### **Conclusion**

In summary, we have developed a low-cost and scalable bottom-up growth process of ZnO NWs, with the control of both NW density and their electrical properties. From the experimental observations, we found that the concentration of ammonium hydroxide plays a crucial role in controlling the NW area density. With a careful manipulation of the amount of ammonium hydroxide in the solution, we demonstrated that the NW density can be controlled over two orders of magnitude. Based on the obtained results, we proposed the growth mechanism governing the density controlled synthesis of ZnO NWs. It is hypothesized that the amount of ammonium hydroxide has a direct efect over the concentration of Zn (II) complexes which will largely afect the Zn solubility in the solution. Consequently, the supersaturation of the growth solution can be controlled and so, the number of nuclei over the substrate. Furthermore, the efect of NH4OH addition over the electrical properties of the ZnO NWs was evaluated by fabricating single NW-FETs. It was observed that the free charge carrier density increases from  $4.3 \times 10^{16}$  to  $2 \times 10^{17}$  cm<sup>-3</sup> while field-effect mobility decreases from 3.8 to 0.35 cm<sup>2</sup>/Vs, as the NH<sub>4</sub>OH concentration increases from 0 to 40mM, hinting the creation of extra point defects with the addition of NH4OH in the growth solution. Tis study presents a useful method to control the morphology, density and electrical properties of ZnO NWs obtained by hydrothermal growth on seedless Au substrates. Such a work will pave the way for ZnO NW's efficient use into the development of flexible electronic and electromechanical devices, such as piezoelectric nanogenerators.

#### **References**

- 1. Wang, X. *et al*. Piezoelectric feld efect transistor and nanoforce sensor based on a single ZnO nanowire. *Nano Lett.* **6**, 2768–2772  $(2006)$ .
- 2. Hu, Y., Lin, L., Zhang, Y. & Wang, Z. L. Replacing a battery by a nanogenerator with 20 v output. *Adv. Mater.* **24**, 110–114 (2012).
- 3. Yang, Y. et al. Pyroelectric Nanogenerators for Harvesting Thermoelectric Energy. *Nano Lett.* **12**, 2833-2838 (2012).
	- 4. Dahiya, A. S. *et al*. Zinc oxide sheet feld-efect transistors. *Appl. Phys. Lett.* **3**, 33105 (2015).
	- 5. Dahiya, A. S. *et al*. Single-crystalline ZnO sheet Source-Gated Transistors. *Sci. Rep.* **6**, 19232 (2016).
	- 6. Opoku, C. *et al*. Fabrication of high performance feld-efect transistors and practical Schottky contacts using hydrothermal ZnO nanowires. *Nanotechnology* **26**, 355704 (2015).
- 7. Marel, V. D., Beek, V. D. & Superconducting, P. H. High-performance thin-flm transistors using semiconductor nanowires and nanoribbons. *Nature* **425**, 274–278 (2003).
- 8. Guo, W., Zhang, M., Banerjee, A. & Bhattacharya, P. Catalyst-free InGaN/GaN nanowire light emitting diodes grown on (001) silicon by molecular beam epitaxy. *Nano Lett.* **10**, 3356–3359 (2010).
- 9. Heo, Y. W. *et al*. Pt/ZnO nanowire Schottky diodes. *Appl. Phys. Lett.* **85**, 3107–3109 (2004).
- 10. Wang, Z. L. Zinc oxide nanostructures: growth, properties and applications. *Phys. Condens. Matter* **16**, 829–858 (2004).
- 11. Greene, L. E., Yuhas, B. D., Law, M., Zitoun, D. & Yang, P. Solution-Grown Zinc Oxide Nanowires. *Inorg. Chem.* **45**, 7535–7543  $(2006)$
- 12. Léonard, F. & Talin, A. A. Electrical contacts to one- and two-dimensional nanomaterials. *Nat. Nanotechnol.* **6**, 773–783 (2011).
- 13. Susner, M. A. *et al*. Catalyst-free ZnO nanowires on silicon by pulsed laser deposition with tunable density and aspect ratio. *Phys. E Low-dimensional Syst*. *Nanostructures* **62**, 95–103 (2014).
- 14. Kaps, S. *et al*. Piezoresistive Response of Quasi-One-Dimensional ZnO Nanowires Using an *in Situ* Electromechanical Device. *ACS Omega* **2**, 2985–2993 (2017).
- 15. Reimer, T. *et al*. Single step integration of ZnO Nano-and microneedles in Si trenches by novel fame transport approach: Whispering gallery modes and photocatalytic properties. *ACS Appl. Mater. Interfaces* **6**, (7806–7815 (2014).
- 16. Mishra, Y. K. *et al*. Fabrication of macroscopically fexible and highly porous 3D semiconductor networks from interpenetrating nanostructures by a simple fame transport approach. *Part. Part. Syst. Charact.* **30**, 775–783 (2013).
- 17. Faraji, N. *et al*. Visible-Light Driven Nanoscale Photoconductivity of Grain Boundaries in Self-Supported ZnO Nano- and MicrostructuredPlatelets. *Adv. Electron. Mater.* **2**, 1–7 (2016).
- 18. Dahiya, A. S. *et al*. Controlled growth of 1D and 2D ZnO nanostructures on 4H-SiC using Au catalyst. **9**, 1–9 (2014).
- 19. Yin, Z. *et al*. Electrochemical Deposition of ZnO Nanorods on Transparent Reduced Graphene Oxide Electrodes for Hybrid Solar Cells. *small nanomicro* **6**, 307–312 (2010).
- 20. Richardson, J. J. & Lange, F. F. Controlling Low Temperature Aqueous Synthesis of ZnO. 2. A Novel Continuous Circulation Reactor. *Cryst. Growth Des.* **9**, 2570–2575 (2009).
- 21. Zhu, G., Wang, A. C., Liu, Y., Zhou, Y. & Wang, Z. L. Functional electrical stimulation by nanogenerator with 58 v output voltage. *Nano Lett.* **12**, 3086–3090 (2012).
- 22. Zheng, N. *et al*. *In-situ* pull-of of ZnO nanowire from carbon fber and improvement of interlaminar toughness of hierarchical ZnO nanowire/carbon fber hydrid composite laminates. *Carbon N. Y.* **110**, 69–78 (2016).
- 23. Yang, D. *et al*. Patterned growth of ZnO nanowires on flexible substrates for enhanced performance of flexible piezoelectric nanogenerators. *Appl. Phys. Lett.* **110**, 63901 (2017).
- 24. Riley, C. T. *et al*. Plasmonic tuning of aluminum doped zinc oxide nanostructures by atomic layer deposition pss. *Phys. Status Solidi RRL* **8**, 948–952 (2014).
- 25. V.Consonni, E.Sarigiannidou, E. A. & A.Bocheux, S. G. Selective Area Growth of Well-Ordered ZnO Nanowire Arrays with. *ACS Nano* **8**, 4761–4770 (2014).
- 26. Wei, Y. *et al*. Wafer-Scale High-Troughput Ordered Growth of Vertically Aligned ZnO Nanowire Arrays. *Nano Lett.* **10**, 3414–3419 (2010).
- 27. Xu, S., Lao, C., Weintraub, B. & Lin, Z. Density-controlled growth of aligned ZnO nanowire arrays. *J. Mater. Res.* **23**, 20 (2008).
- 28. Xu, S. *et al*. Optimizing and improving the growth quality of ZnO nanowire arrays guided by statistical design of experiments. *ACS Nano* **3**, 1803–1812 (2009).
- 29. Weintraub, B., Deng, Y. L. & Wang, Z. L. Position-controlled seedless growth of ZnO nanorod arrays on a polymer substrate via wet chemical synthesis. *J. Phys. Chem. C* **111**, 10162–10165 (2007).
- 30. Murillo, G., Lozano, H., Cases-utrera, J., Lee, M. & Esteve, J. Improving Morphological Quality and Uniformity of Hydrothermally Grown ZnO Nanowires by Surface Activation of Catalyst Layer. *Nanoscale Res. Lett*. 4–11, [https://doi.org/10.1186/s11671-017-](http://dx.doi.org/10.1186/s11671-017-1838-x) [1838-x](http://dx.doi.org/10.1186/s11671-017-1838-x) (2017).
- 31. Chen, L.-Y., Yin, Y.-T., Chen, C.-H. & Chiou, J.-W. Influence of Polyethyleneimine and Ammonium on the Growth of ZnO Nanowires by Hydrothermal Method. *J. Phys. Chem. C* **115**, 20913–20919 (2011).
- 32. Dahiya, A. S. *et al*. Flexible Organic/Inorganic Hybrid Field-Efect Transistors with High Performance and Operational Stability. *ACS Appl. Mater. Interfaces* **9**, 573–584 (2017).
- 33. Barbagiovanni, E. G. *et al*. Radiative mechanism and surface modifcation of four visible deep level defect states in ZnO nanorods. *Nanoscale* **8**, 995–1006 (2016).
- 34. Barbagiovanni, E. G. *et al*. Universal model for defect-related visible luminescence in ZnO nanorods. *rsc Adv.* **6**, 73170–73175 (2016).
- 35. Allen, M. W. & Durbin, S. M. Infuence of oxygen vacancies on Schottky contacts to ZnO. *Appl. Phys. Lett.* **92**, 21–24 (2008).
- 36. Schvartzman, M., Tsivion, D., Mahalu, D., Raslin, O. & Joselevich, E. Self-integration of nanowires into circuits via guided growth. *Proc. Natl. Acad. Sci.* **110**, 15195–15200 (2013).

#### **Acknowledgements**

This project has received funding from the ECSEL JU under grant agreement N° 692482. This JU receives support from the European Union's H2020 research and innovation programme and France, Netherlands, Denmark, Belgium, Germany, Czek Republic, Spain. The Authors are also grateful for the supports from Region Centre (MEPS project 2015–2018) and National Research Agency (ANR-14-CE08-0010-01). The authors also thank Mustapha Zaghrioui for his technical assistance during Raman spectroscopy measurements on ZnO NWs.

#### **Author Contributions**

S.B., G.P.V. and D.A. designed the experiments. S.B. performed the synthesis and majority of structural/ morphological analysis of the ZnO NWs. A.S.D. fabricated single ZnO NW-FETs. A.S.D. carried out all electrical characterizations of fabricated transistors. The drafting of the manuscript has been done by S.B. and F.M. K.N., G.P.V. and D.A. did critical revisions of the manuscript. All authors have read and approved the fnal manuscript.

#### **Additional Information**

**Competing Interests:** The authors declare that they have no competing interests.

**Publisher's note:** Springer Nature remains neutral with regard to jurisdictional claims in published maps and institutional afliations.

**Co O Open Access** This article is licensed under a Creative Commons Attribution 4.0 International License, which permits use, sharing, adaptation, distribution and reproduction in any medium or format, as long as you give appropriate credit to the original author(s) and the source, provide a link to the Creative Commons license, and indicate if changes were made. The images or other third party material in this article are included in the article's Creative Commons license, unless indicated otherwise in a credit line to the material. If material is not included in the article's Creative Commons license and your intended use is not permitted by statutory regulation or exceeds the permitted use, you will need to obtain permission directly from the copyright holder. To view a copy of this license, visit [http://creativecommons.org/licenses/by/4.0/.](http://creativecommons.org/licenses/by/4.0/)

 $© The Author(s) 2017$